
Oral presentation | 6 Thin Films and Surfaces | 6.6 Probe Microscopy

[19a-143-1~8]6.6 Probe Microscopy

Masayuki Abe(阪大)

Wed. Sep 19, 2018 9:30 AM - 11:45 AM 143 (143)

△ : Presentation by Applicant for JSAP Young Scientists Presentation Award

▲ : English Presentation

▼ : Both of Above

No Mark : None of Above

9:30 AM - 10:00 AM

[19a-143-1][JSAP Best Review Paper Award Speech] High resolution characterizations of fine structure of semiconductor device and material using scanning nonlinear dielectric microscopy

○Yasuo Cho¹ (1.Tohoku Univ.)

Keywords:JSAP Best Review Paper Award Speech